

APPARATUS AND METHOD FOR DETECTING WAFER POSITION

Inventor: CHEN, Jun-Ming et al.

Docket No. 4425-308

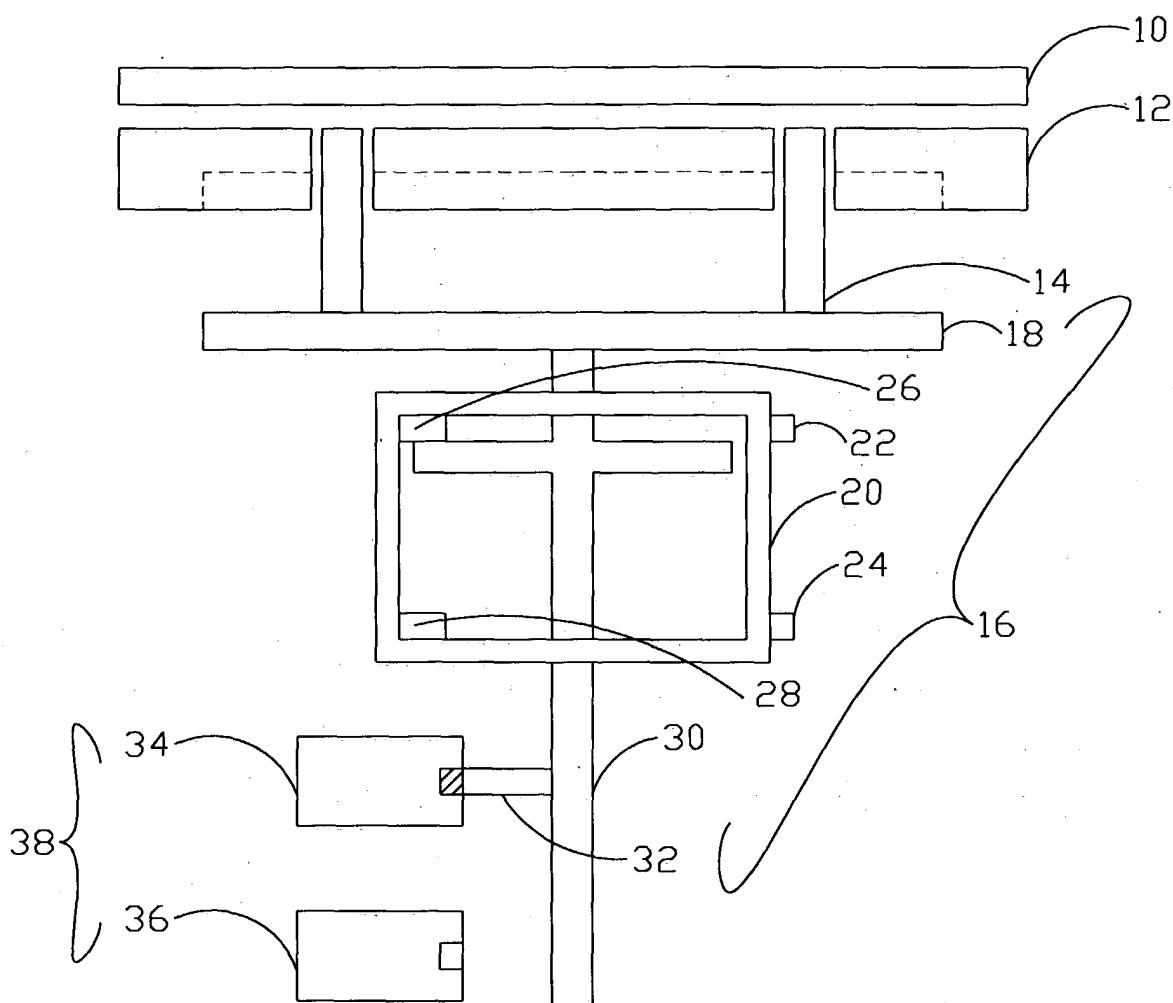


FIG.1A(Prior Art)

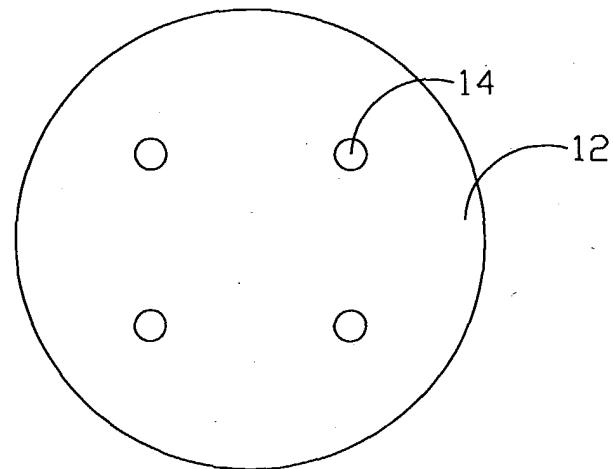


FIG.1B(Prior Art)

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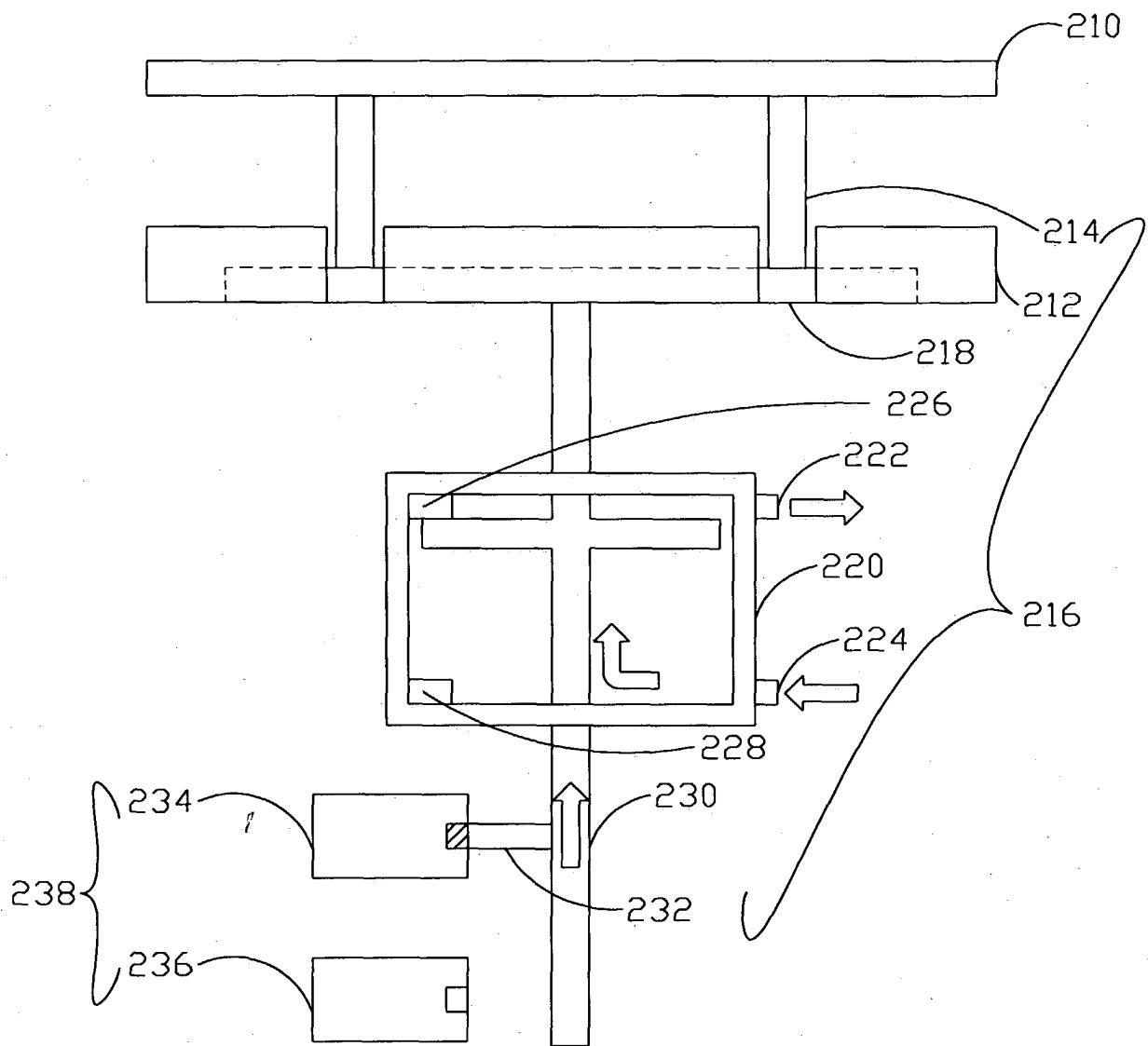


FIG.2A(Prior Art)

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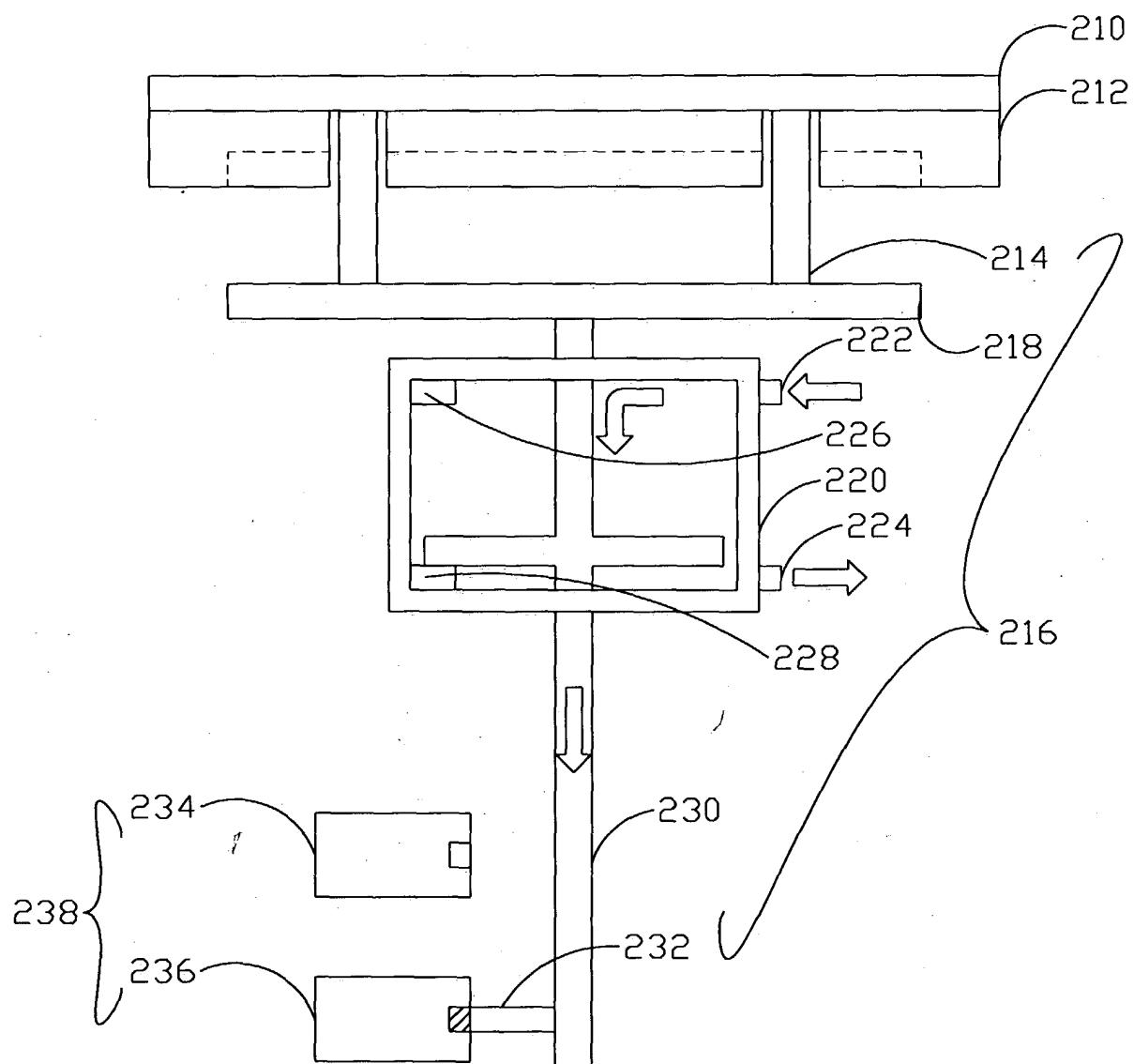


FIG.2B(Prior Art)

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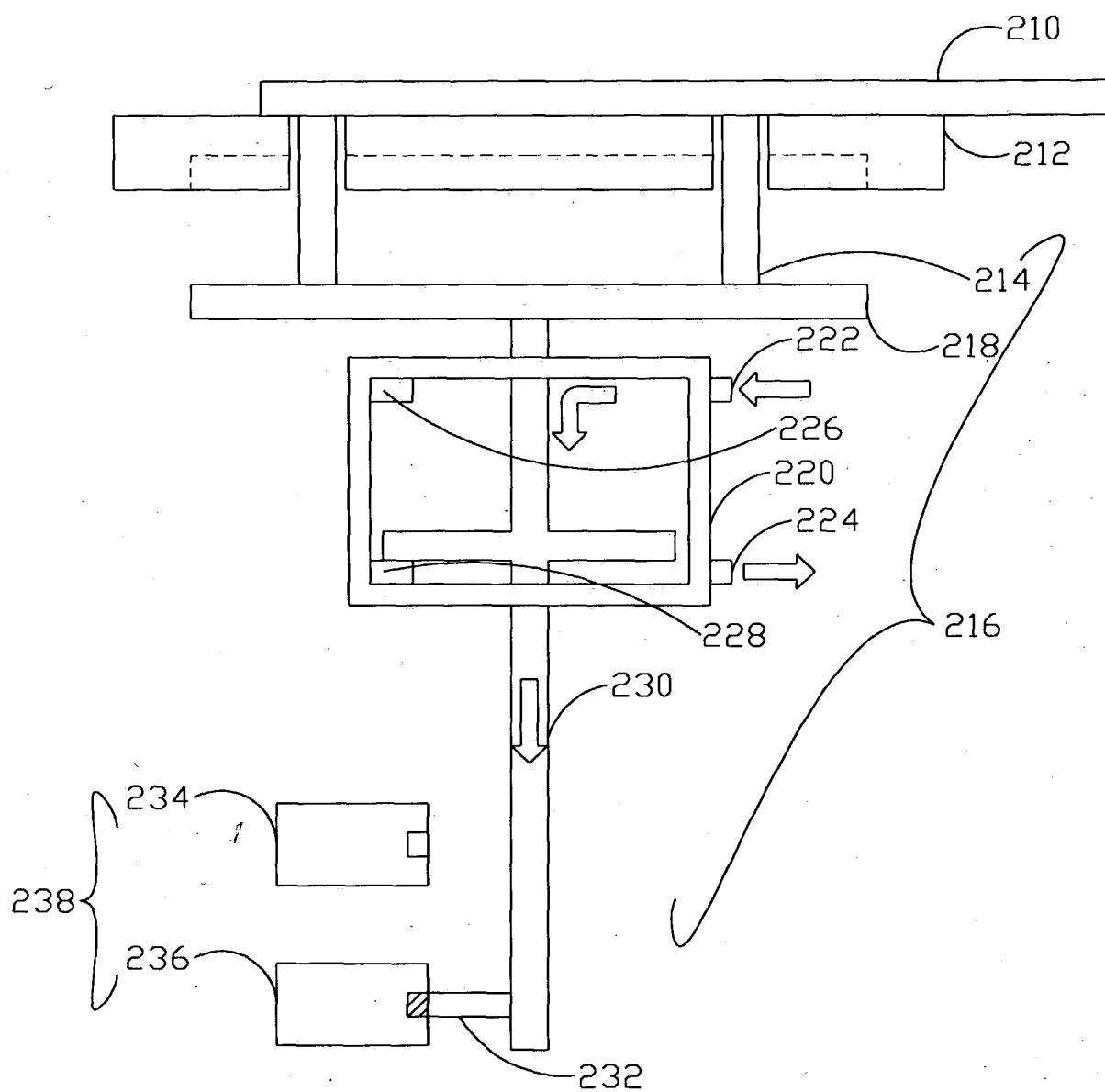


FIG.2C(Prior Art)

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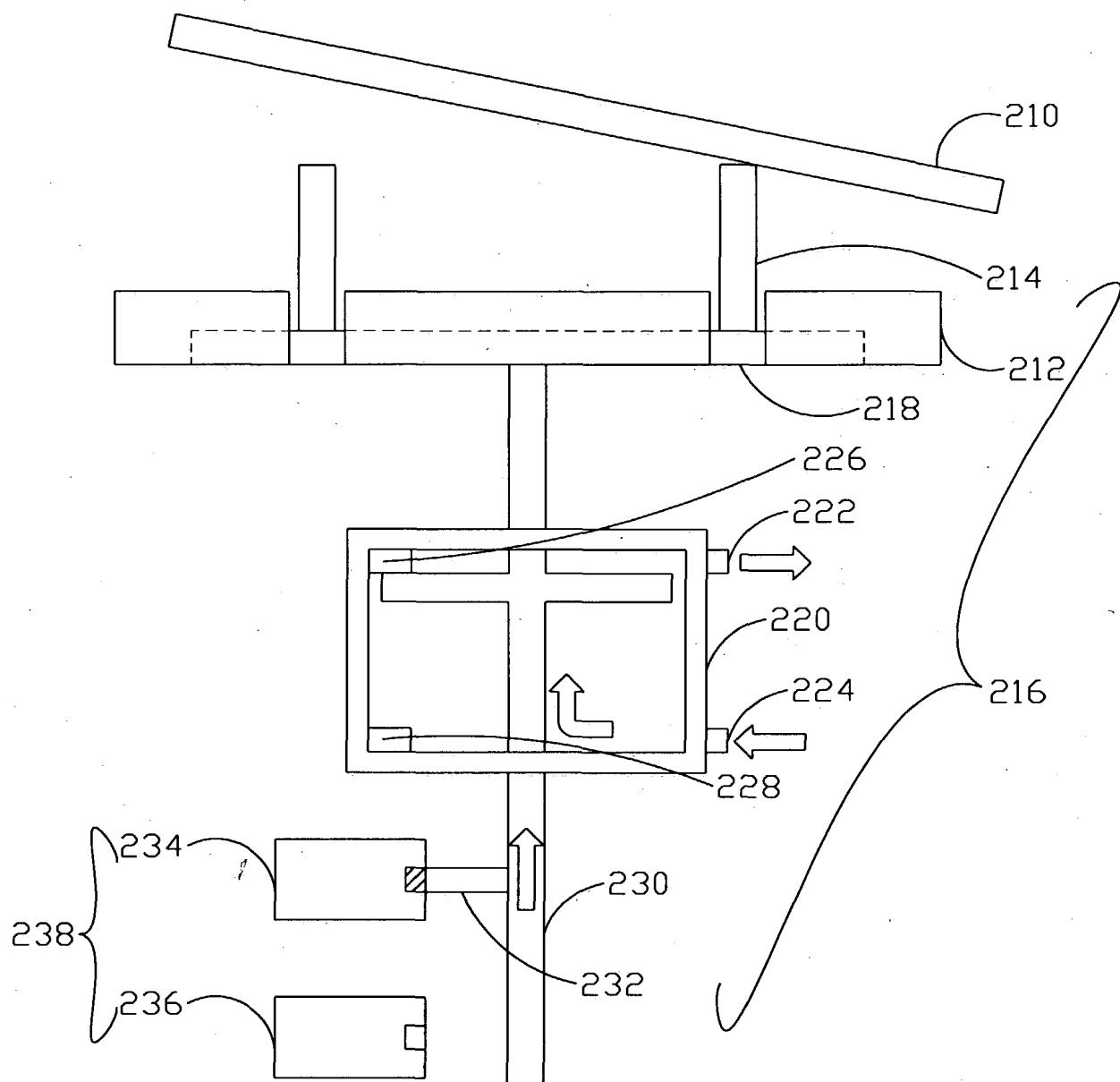


FIG.2D(Prior Art)

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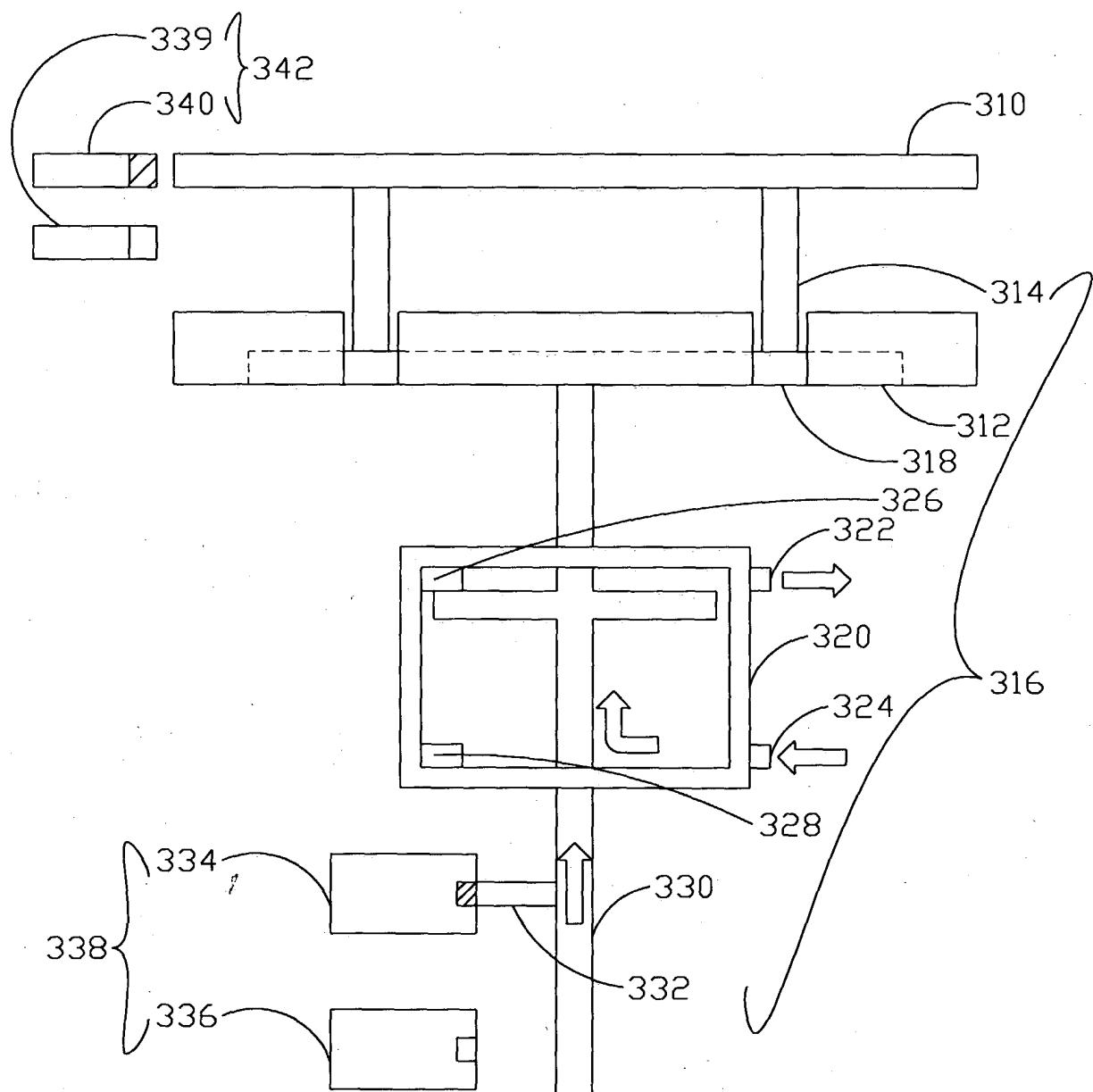


FIG.3A

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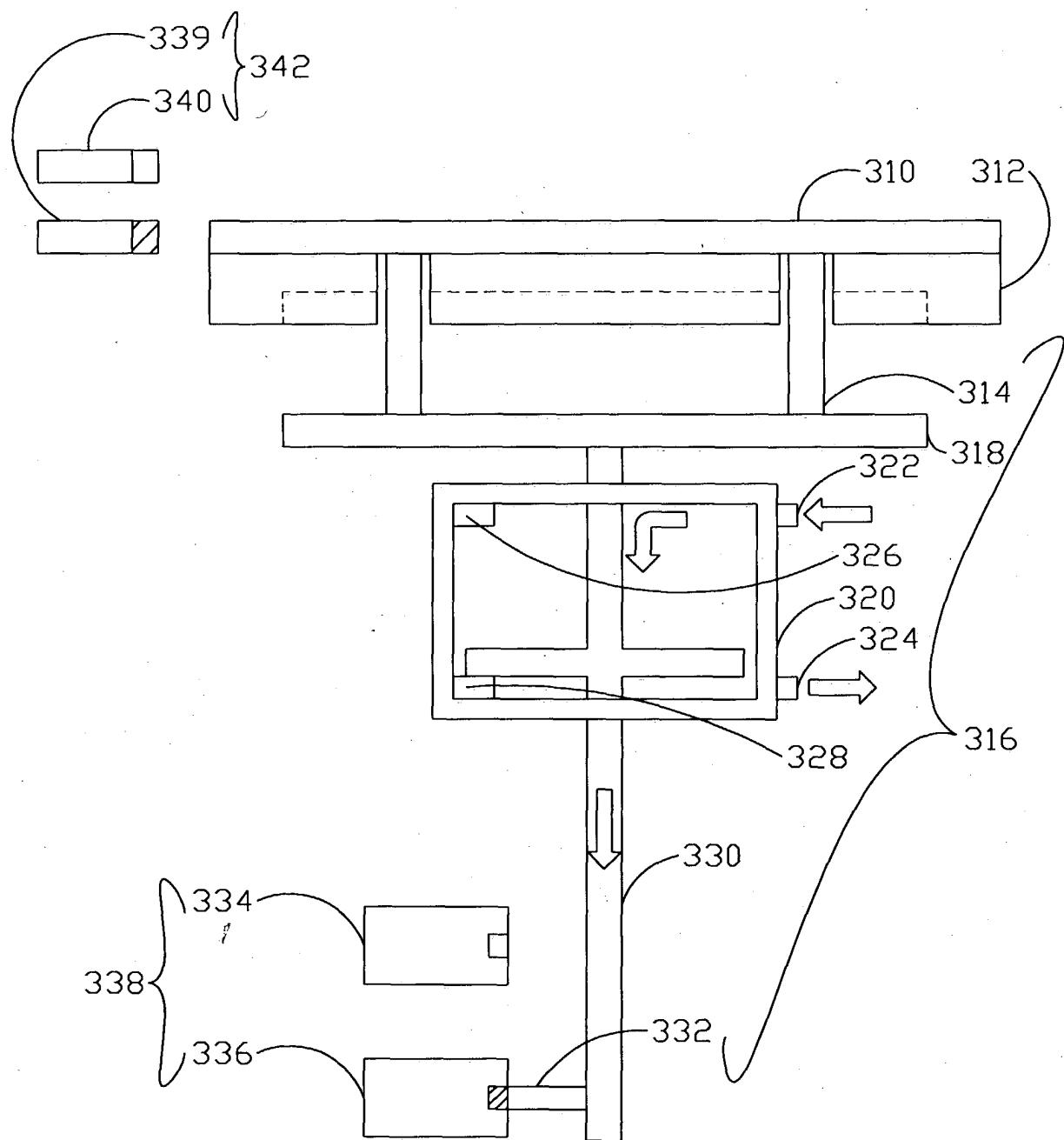


FIG.3B

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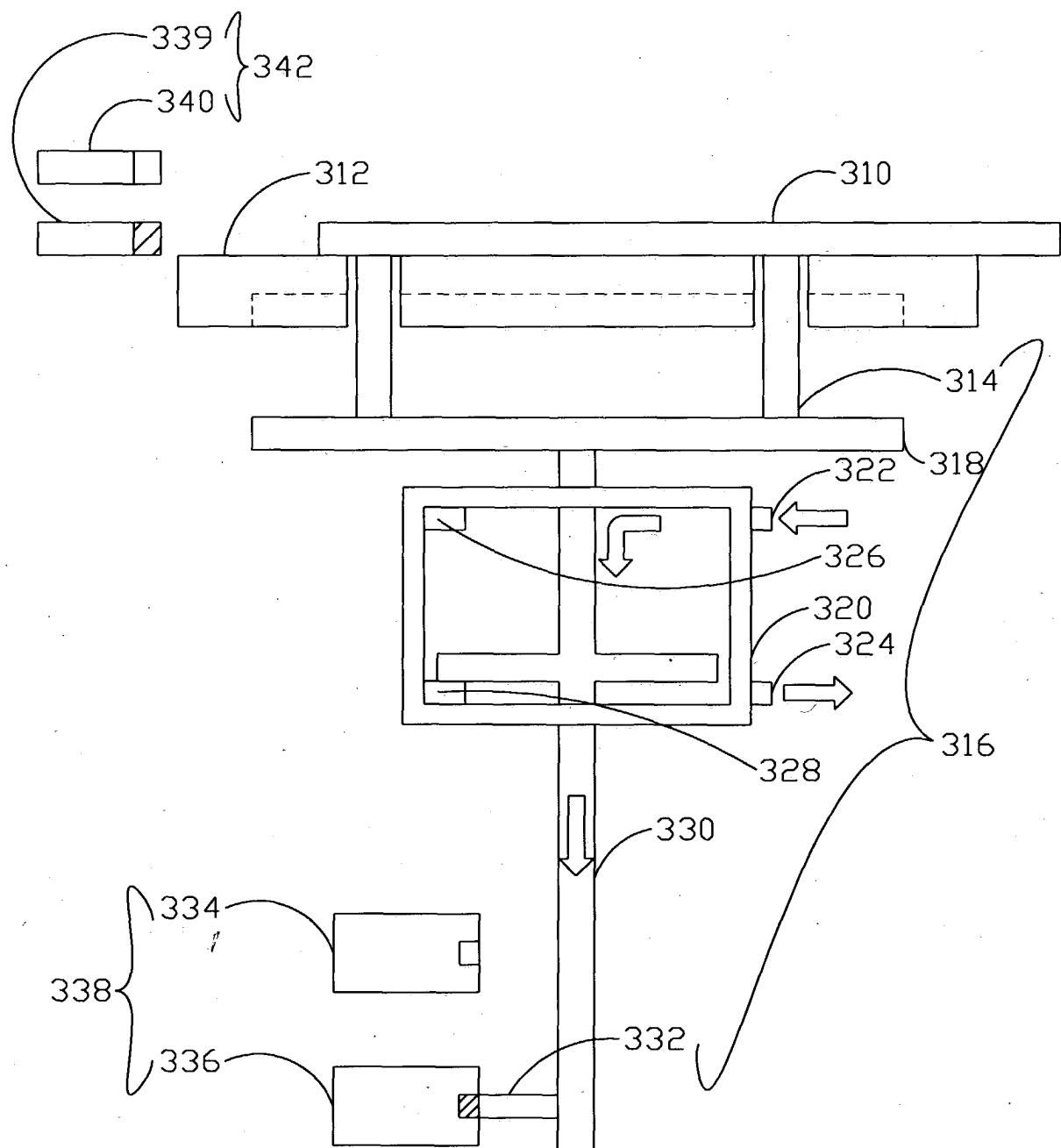


FIG.3C

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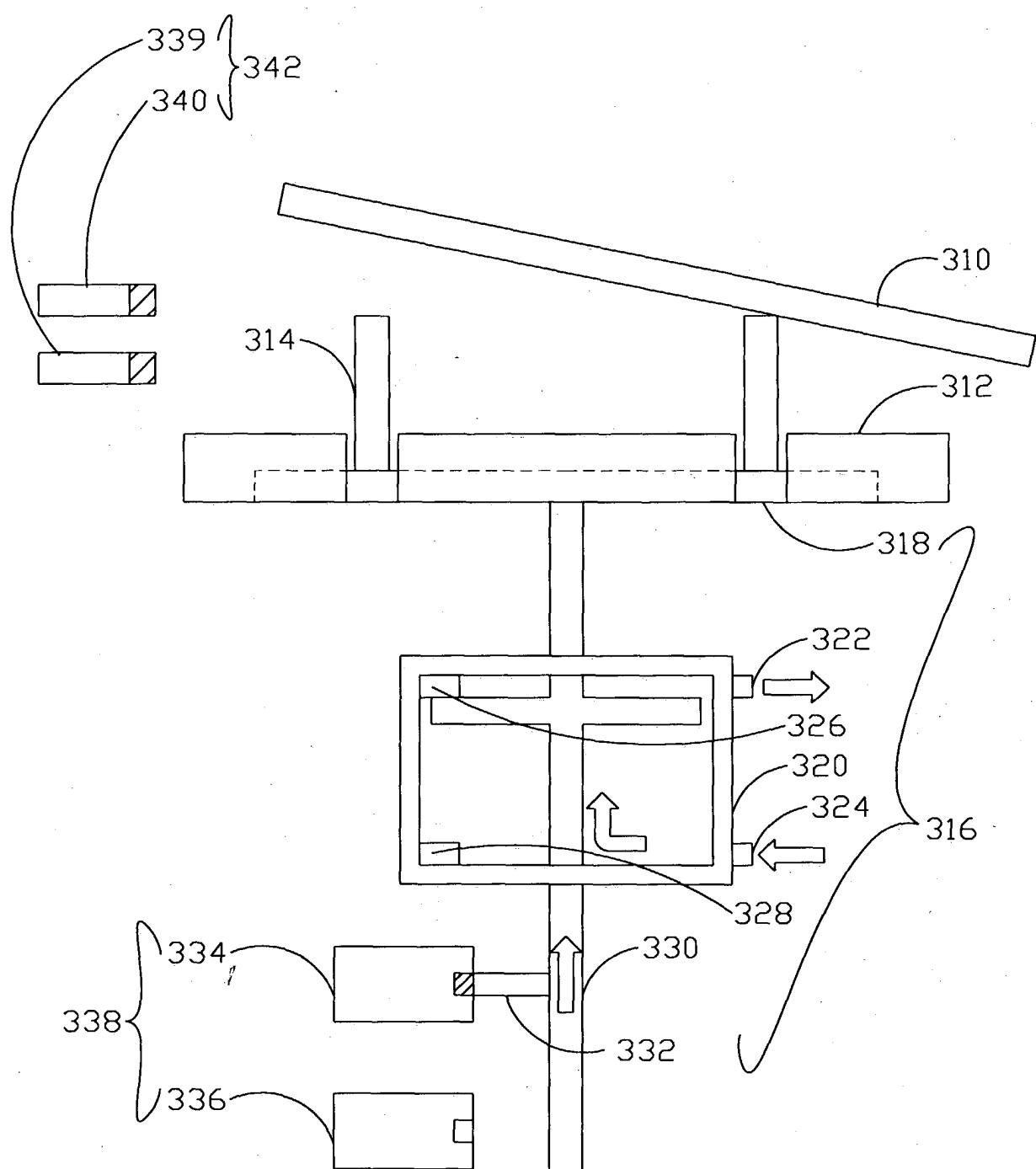


FIG.3D

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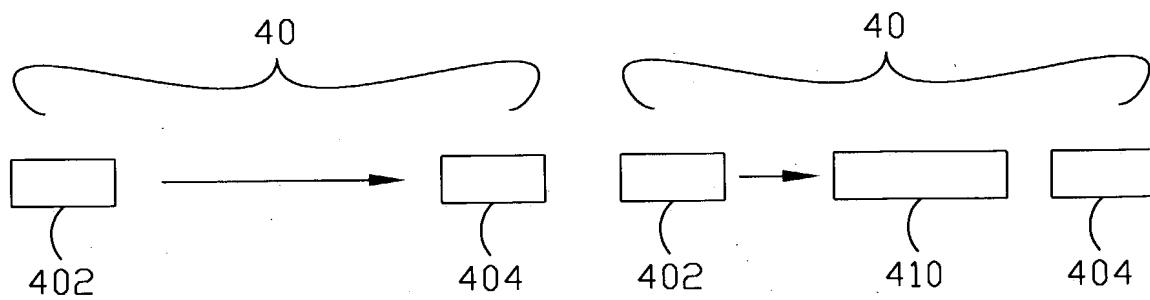


FIG.4A

FIG.4B

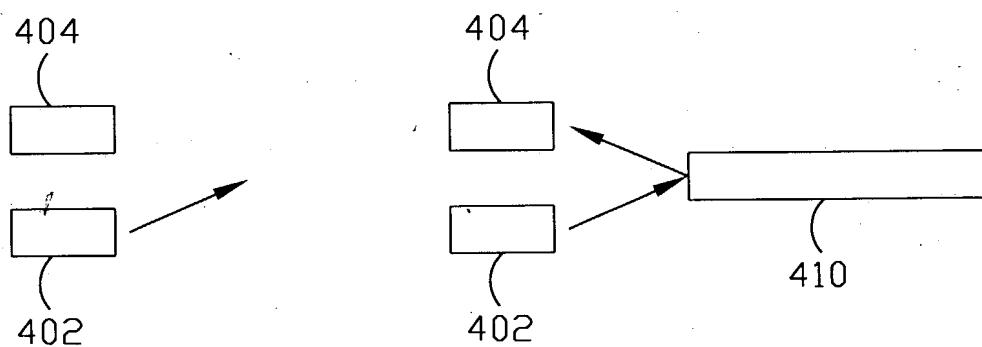


FIG.4C

FIG.4D

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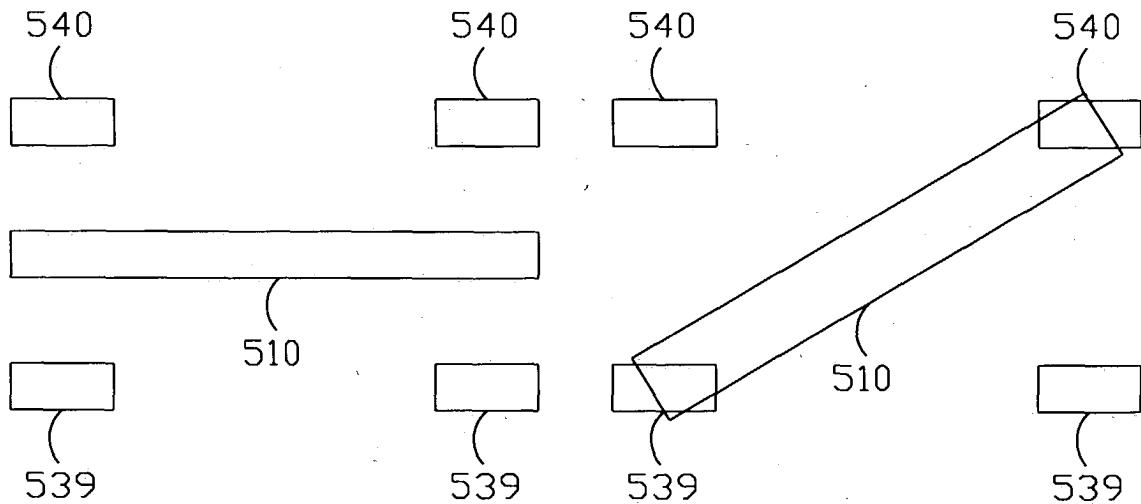


FIG.5A

FIG.5B

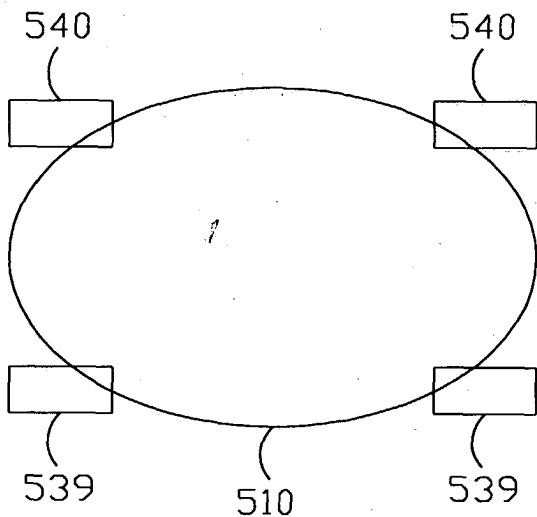


FIG.5C